L	Hits	Search Text	DB	Time stamp
Number				
55	3	("4575748" "4578697" "4789889").PN.	USPAT	2003/08/04
A	i			13:14
64	360	29/827,832,840,841,838,839.ccls. and	USPAT;	2003/08/04
		lead\$1frame	EPO; JPO	13:56
65	155	(29/827,832,840,841,838,839.ccls. and	USPAT;	2003/08/04
		lead\$1frame) and encapsulat\$3	EPO; JPO	13:57
95	6	257/666-676.ccls. and lead\$1frame and	USPAT;	2003/08/04
		arcuate	US-PGPUB	14:52
96	6	257/666-676.ccls. and lead\$1frame and	USPAT;	2003/08/04
- V		arcuate	EPO; JPO	14:52
97	42	257/666-676.ccls. and lead\$1frame and	USPAT;	2003/08/04
		spacing and constant	EPO; JPO	16:08
98	1 8	("3680206" "3936930" "3971610"	USPAT	2003/08/04
		"4000054" "4116517" "4403272"		16:07
		"4758459" "4813129").PN.		
99	1	4453795.pn.	USPAT;	2003/08/04
			EPO; JPO	16:08
108	45	5313096.URPN.	USPAT	2003/08/04
				16:20
129	55	5200362.URPN.	USPAT	2003/08/04
				16:37
134	9	("4743956" "4974053" "5115298"	USPAT	2003/08/04
		"5138430" "5200364" "5313102"		18:03
		"5397916" "5457340" "5569956").PN.		
-	2	(leadframe).ti. and (harrison).in.	USPAT;	2003/06/26
			US-PGPUB;	17:08
:			EPO; JPO	
-	9	("4743956" "4974053" "5115298"	USPAT	2003/06/26
		"5138430" "5200364" "5313102"		17:05
1	•	"5397916" "5457340" "5569956").PN.		
-	1387	lead\$1frame and encapsulat\$3	USPAT;	2003/06/26
1			EPO; JPO	17:09
-	76		USPAT;	2003/06/26
1		conductive adj1 pad	EPO; JPO	17:40
_	535	encapsulat\$3 and print\$3 and lead and	USPAT;	2003/06/26
		conductive adj1 pad	EPO; JPO	17:41

US 5313102 A	US 5313102 A 19940517 Integrated circuit device having a polyimide moisture barrier coating	257/787	257/787 Lim, Thiam B. et al.
US 5457340 A	US 5457340 A 19951010 Leadframe with power and ground planes	257/666	257/666 Templeton, Jr., Thomas H. et
US 6362426 B1	US 6362426 B1 20020326 Radiused leadframe	174/52.2	174/52.2 Harrison, Ronnie M. et al.
US 4743956 A	US 4743956 A 19880510 Offset bending of curvaceously planar radiating leadframe leads in semiconductor chip packaging	257/674	257/674 Olla, Michael A. et al.
US 5138430 A	US 5138430 A 19920811 High performance versatile thermally enhanced IC chip mounting	257/712	257/712 Gow, 3rd, John et al.
US 4974053 A	JS 4974053 A 19901127 Semiconductor device for multiple packaging configurations	257/666	257/666 Kinoshita, Mitsuya et al.
US 5594234 A	US 5594234 A 19970114 Downset exposed die mount pad leadframe and package	257/676	257/676 Carter, Jr., Buford H. et al.
US 6165021 A	US 6165021 A 20001226 Connector for a smart card reader apparatus and card reader comprising same	439/630	439/630 Bourne, Frederic
US 5313096 A	US 5313096 A 19940517 IC chip package having chip attached to and wire bonded within an overlying substrate	257/686	257/686 Eide, Floyd K.
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US 5036380 A	JS 5036380 A 19910730 Burn-in pads for tab interconnects	257/668	257/668 Chase, Richard A.
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US 5589402 A	US 5589402 A 19961231 Process for manufacturing a package for mating with a bare semiconductor die	438/64	Ramsey, Kenneth C. et al.
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US 5200362 A	US 5200362 A 19930406 Method of attaching conductive traces to an encapsulated semiconductor die using a removable tran 29/841	n29/841	Lin, Paul T. et al.
US 4807018 A	US 4807018 A 19890221 Method and package for dissipating heat generated by an integrated circuit chip	257/675	257/675 Cellai, Marino
US 5939775 A	JS 5939775 A 19990817 Leadframe structure and process for packaging intergrated circuits	257/667	257/667 Bucci, Giuseppe D. et al.
US 4453795 A	US 4453795 A 19840612 Cable-to-cable/component electrical pressure wafer connector assembly	439/361	439/361 Moulin, Norbert L.